



DO NOT ENTER 7/20/2006 QVJ

Attorney Docket No. 51876.P542

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Patent Application of:	
Tae-Woo Jung et al.	Examiner: Quovaunda Jefferson
Serial No. 10/750,021	Art Unit: 2823
Filed: December 30, 2003	
For: METHOD FOR FABRICATING SEMICONDUCTOR DEVICE HAVING TRENCH TYPE DEVICE ISOLATION LAYER	

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Dear Commissioner:

In response to the Final Office Action mailed May 17, 2005, regarding the above-referenced application, Applicant respectfully requests entry of the amendment set forth below in consideration of the remarks that follow.